



## INFORMATION DISCLOSURE

### CITATION

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APPLICANT

YAMAMOTO et al.

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**GROUP**

1753

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## U.S. PATENT DOCUMENTS

[illegible]

## FOREIGN PATENT DOCUMENTS

[illegible]

**OTHER DOCUMENTS (including Author, Title, Date, Pertinent pages, etc.)**

|     |  |
|-----|--|
| ADD | "Effects of Substrates with Different Surface Morphology on Microcrystalline Silicon Solar Cells", Nasuno et al., page 829, 6a-C-6, 9-2000.    |
| ADD | "Effects of Substrates with Different Surface Morphology on Microcrystalline Silicon Solar Cells", Nasuno et al., April 2001, pages L-303-L305 |
| ADD | "Microcrystalline Silicon Thin-Film Solar Cells Prepared at Low Temperature Using PECVD", Nasuno et al., Korea, 2001, pages 791-794            |
| ADD | "Microcrystalline Silicon Thin-Film Solar Cells Prepared at Low Temperature Using RF-PECVD", Nasuno et al., Sept. 2000                         |
| ADD | "Microcrystalline Silicon Thin-Film Solar Cells Prepared at Low Temperature", Nasuno et al., 2001, pages A15.5.1-12                            |

\*Examiner

Date Considered

8/14/03

Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to application.

Form PTO-FB-A820 (Also PTO-1449)